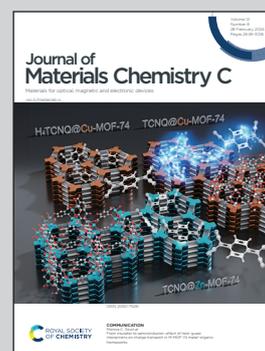


Showing collaborative research from Bar-Ilan University, Israel, National Technical University of Athens, Greece, Tel Aviv University, Israel, University of Massachusetts, USA, and Graphenea, Spain.

From monolayer to thin films: engineered bandgap in CVD grown $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ topological insulator alloys

Using chemical vapor deposition (CVD), the scalable growth of topological insulator alloys $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ with composition-tunable bandgap and free from surface-state pinning was achieved. This research paves the way for the controlled growth of topological insulators, suitable for quantum optoelectronics and spintronics applications.

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From monolayer to thin films: engineered bandgap in CVD grown $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ topological insulator alloys†

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Topological insulators, a class of materials possessing bulk bandgap and metallic surface states with a topological nontrivial symmetry, are considered promising candidates for emerging quantum and optoelectronic applications. However, achieving scalable growth and control over the parameters including thickness, carrier density, bulk bandgap, and defect density remains a challenge in realizing such applications. In this work, we show the scalable growth of topological insulator alloys $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ and demonstrate composition-tunable bandgap, using chemical vapor deposition (CVD). A bandgap increase of up to $\sim 40\%$ at a sulfur concentration of $\sim 15\%$ is demonstrated. Correspondingly, the real part (n) of the refractive index is reduced in the alloy by $\sim 25\%$ relative to that of Bi_2Se_3 . Additionally, electronic transport measurements indicate a bulk p-type doping and field-effect tunable metallic surface states of the alloy. This work paves the way for the controlled growth of topological insulators, free from surface-state pinning, suitable for quantum optoelectronics and spintronics applications.

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Introduction

Topological insulators (TIs), a class of materials having a bulk bandgap and metallic states,^{1–4} are considered promising for novel applications in electronics and optoelectronics.^{5–10} This is due to the several interesting properties introduced by their

surface/edge states such as spin-momentum locking, resulting in spin-polarized transport and significant suppression of backscattering by impurities.¹¹ The topological properties are mainly induced by relatively strong spin-orbit coupling interaction,^{12,13} and under certain conditions, may also be augmented by applying an electric field.¹²

Bi_2Se_3 is one of the most studied three-dimensional (3D) TIs due to its \mathbb{Z}_2 topology manifested in a band structure with a single Dirac cone at the gamma point and a relatively large, direct bandgap of ~ 0.3 eV.^{11,14–17} However, the material is usually heavily n-doped, likely due to shallow defect states emerging from Se vacancies that act as donors. This results in the pinning of the Fermi level to the conduction band, leading to bulk conduction rather than surface-dominated conduction of charge carriers. This issue is one of the main challenges in device applications of Bi_2Se_3 and other TIs.^{11,14,15,18}

The pursuit of TI materials having large bulk bandgaps also stems from their importance for future room-temperature spintronic applications.^{1,19,20} In this respect, alloying presents a promising means of tuning the electronic properties of Bi_2Se_3 ,^{15,21–23} with the potential to address both the problems of Fermi-level pinning and bandgap engineering. By utilizing a chemical composition of higher stability in the alloy, the density of natural chalcogen vacancies decreases and suppresses the natural n-doping of Bi_2Se_3 .

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† Electronic supplementary information (ESI) available: $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ synthesis, mass spectroscopy mapping of the grown $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ crystals, diffusion processes of chalcogen atoms, Raman spectroscopy, X-ray diffraction, lattice parameters–sulfur content relation by DFT calculations, reflection measurements, optical constants, and temperature-dependent resistance measurements. See DOI: <https://doi.org/10.1039/d3tc03428c>



Table 1 $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ growth parameters and morphology. See Fig. S1 for SEM images of the various morphologies

Substrate	Growth temperature [°C]	Growth time [min.]	Substrate temperature [°C]	Morphology
Si/SiO ₂	570	10	440	Isolated hexagonal crystals with growth direction perpendicular to the substrate (Fig. S1a, ESI)
Sapphire	580	180	450	Hexagonal crystals on a scale of ~50 μm clustered in vertical growth (Fig. S1b, ESI)
Monolayer graphene on Si/SiO ₂	580	60	460	Isolated hexagonal crystals on a scale of up to 15 μm (Fig. S1c, ESI)
		120	440	Isolated hexagonal crystals on a scale of up to 20 μm (Fig. S1d, ESI)
		180	410	Continuous layers (Fig. S1e, ESI)

The implementation of practical electronic and optoelectronic devices requires repeatable growth of high-quality active materials with uniformity over large areas. In this context, chemical vapor deposition (CVD) is a well-known method for scalable deposition of transition metal dichalcogenides (TMDCs),^{24,25} transition metal oxides (TMOs) such as wafer-scale single-layer amorphous MoO₃,^{26,27} and has also been demonstrated on chalcogenide optical materials.²⁸ CVD grown Bi_2Se_3 crystals, with sizes up to 20 μm, were previously reported as well,²⁹ yet the synthesis of alloyed Bi_2Se_3 has primarily relied on solution-processed techniques and molecular beam epitaxy (MBE).^{15,21,30–32}

Here, we show a CVD growth of Bi_2Se_3 alloyed with sulfur on various substrates, from isolated crystals to continuous films, uniform on a wafer-scale and with a crystal domain size up to ~50 μm. The alloyed crystals present a wider bulk bandgap

(up to 40% larger than pure Bi_2Se_3), p-type doping, and field-effect tunable Fermi-level while maintaining the original structural and topological properties of Bi_2Se_3 .

Results and discussion

Continuous layers and isolated $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ crystals were grown by CVD on various substrates (see Table 1), starting from Bi_2Se_3 powder (Alfa Aesar – 99.999%) and sulfur powder (Sigma Aldrich – 99.5%), as illustrated schematically in Fig. 1a. In short, the growth of $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ was carried out in a quartz tube at the temperatures specified in Table 1 for the Bi_2Se_3 precursor and at 140 °C for the sulfur, at a base pressure of 50 mTorr and N₂ flow rate of 5 sccm (see the ESI† for full synthesis details). The temperature of the substrate (Table 1)

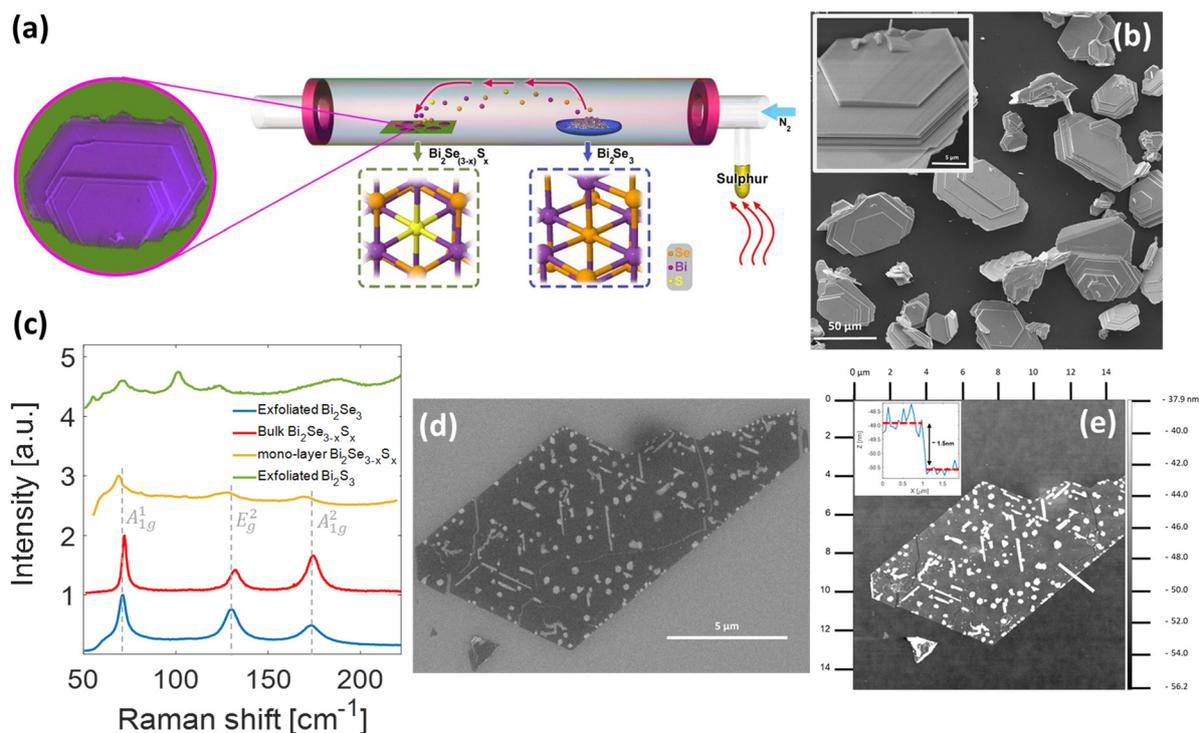


Fig. 1 Growth process and structural characterization of CVD-grown $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$. (a) Schematic illustration of the CVD system and growth process. (b) HRSEM images of the hexagonal grown $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ crystals. (c) Raman spectra of exfoliated Bi_2Se_3 (blue), bulk and monolayer $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ grown by CVD (red and yellow respectively), and exfoliated Bi_2S_3 (green). (d) HRSEM image of monolayer $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ grown by CVD. (e) AFM topography of monolayer $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ grown by CVD, showing (inset) a 1.5 nm step thickness of the flake.



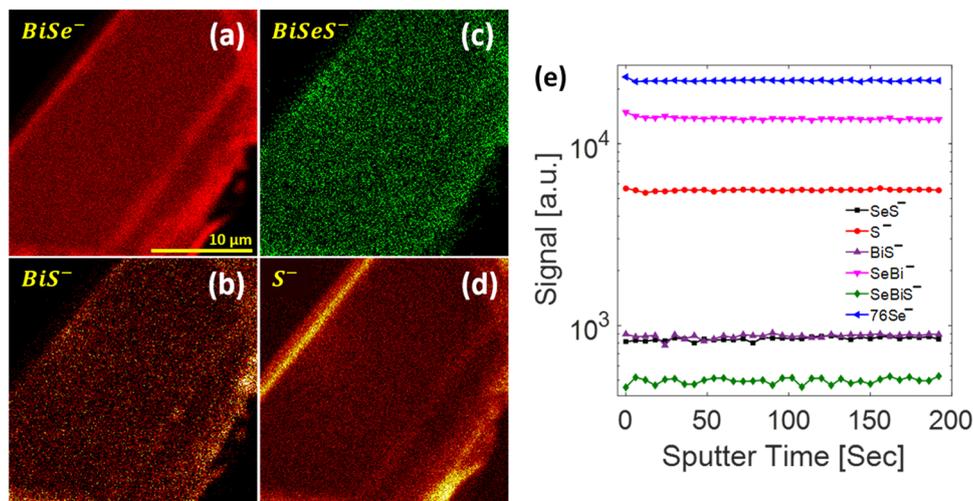


Fig. 2 Time-of-flight secondary ion mass spectroscopy (TOF-SIMS) analysis. Chemical lateral imaging of Bi₂Se_(3-x)S_x flakes using (a) BiSe⁻, (b) BiS⁻, (c) BiSeS⁻, and (d) S⁻ ions. (e) Signal intensity of selected ions as a function of sputtering time (depth).

was controlled by its distance from the Bi₂Se₃ precursor and the temperature at the center of the furnace.

The representative morphology of isolated crystals is presented in Fig. 1b, showing hexagonal domains on a scale of up to 50 μm. However, the morphology depends drastically on the growth substrate and exhibits large variations in the growth products. On a substrate of Si/SiO₂, the hexagonal crystals are oriented vertically to the surface, having minimal contact area with the substrate (Fig. S1a, ESI[†]). On sapphire substrates, multiple crystalline domains grow laterally and vertically from a single seed and overlap each other (Fig. S1b, ESI[†]). In high-vacuum conditions, the growth is dominated by thin crystals and adlayers forming crystal seeds in the principal crystalline directions. The minimal measured thickness is attributed to such a monolayer and was found to be 1.5 nm (see the SEM micrograph and AFM topography in Fig. 1d and e). Interestingly, the growth on graphene-covered Si/SiO₂ is lateral (Fig. S1c and S1d, ESI[†]) and tends to form continuous films (Fig. S1e, ESI[†]). The latter is probably a result of reduced surface

reactivity and enhanced diffusivity of the reactants on the surface of graphene. In all cases, the obtained alloys maintain high uniformity (Fig. 2 and Fig. S2, ESI[†]), owing to the high diffusivity of sulfur in Bi₂Se₃ and its ability to passivate existing vacancies (see Fig. S3 and associated text, ESI[†]).

The Raman signature (Fig. 1c) of bulk and monolayer Bi₂Se_(3-x)S_x (red and yellow lines, respectively) show similar peak positions, with distinct broadening of the peaks in the monolayer crystal compared to that of a bulk crystal. Both thin and thick alloys show shifted spectra relative to pure exfoliated Bi₂Se₃ (Fig. 1c, blue line), as specified in Table S1 (ESI[†]). The Raman spectrum of orthorhombic Bi₂S₃ (Fig. 1c, green line) differs distinctly from the rhombohedral crystals, showing characteristic Raman modes at ~101 and ~189 cm⁻¹ that do not appear in the grown alloy materials. This is further supported by the X-ray diffraction (XRD) pattern of the alloyed samples in which the peaks show proximity to those of the reference exfoliated Bi₂Se₃ sample and agree with the calculated XRD of the rhombohedral structure (Fig. S4, ESI[†]).

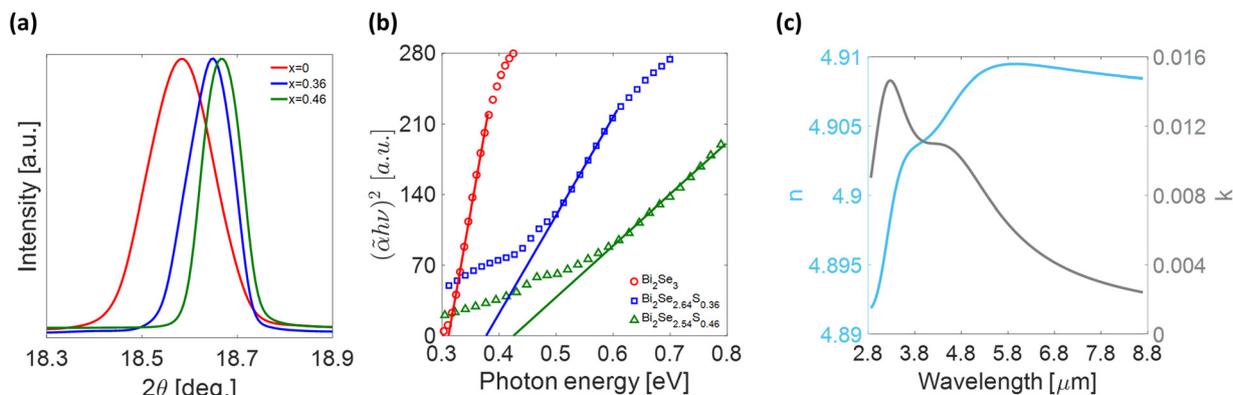


Fig. 3 (a) Illustration of the shift in the crystallographic planes of the alloyed samples relative to those of Bi₂Se₃ (the crystallographic plane 006 is given as an example). (b) Tauc plots for the direct bandgap of exfoliated pure Bi₂Se₃ and sulfur alloyed Bi₂Se₃ samples. (c) Extracted real (*n*, blue line) and imaginary (*k*, gray line) parts of the refractive index of Bi₂Se_{2.64}S_{0.36}.



Table 2 *c*-axis spacing, [%S] and E_g values summary for pure Bi_2Se_3 and sulfur alloyed Bi_2Se_3 samples

Sample	<i>c</i> [Å]	[%S]	<i>x</i>	Chemical formula	E_g [eV]
Bi_2Se_3	28.669	0	0	Bi_2Se_3	$0.31 \pm 1.42 \times 10^{-3}$
$\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ #1	28.586	11.9	0.36	$\text{Bi}_2\text{Se}_{2.64}\text{S}_{0.36}$	$0.38 \pm 1.42 \times 10^{-3}$
$\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ #2	28.561	15.2	0.46	$\text{Bi}_2\text{Se}_{2.54}\text{S}_{0.46}$	$0.43 \pm 2.74 \times 10^{-3}$

From the analysis of XRD measurements of the alloyed crystals (Fig. 3a and Fig. S4b, ESI†), the variation in the *c*-axis spacing was correlated with structurally optimized results of Density Functional Theory (DFT) calculations resolved by relative sulfur concentration (see ESI† for details). In a random alloy, the calculated structure predicts a trend that can be fitted to $c = -4 \times 10^{-5}[\%S]^2 - 6.5 \times 10^{-3}[\%S] + 28.669$ Å (Fig. S5, ESI†), where the constant coefficient (28.669) is the experimental *c* value for pure Bi_2Se_3 . The data for two alloys on monolayer graphene on Si/SiO₂ (90 nm) are summarized in Table 2 relative to Bi_2Se_3 .

The variation in the bandgap values of these samples is given in Table 2. The values were determined by applying the Tauc method on the quantity $\tilde{\alpha}$, which was obtained by employing the Kubelka–Munk (K–M) function (eqn (1))^{33,34} on the reflection spectra of the samples:

$$\tilde{\alpha} = \frac{\alpha}{S} = \frac{(1 - R_\infty)^2}{2R_\infty} \quad (1)$$

where α and S are the absorption and scattering coefficients respectively, and $R_\infty = \frac{R_{\text{sample}}}{R_{\text{standard}}}$ is the reflection of the sample. Pure exfoliated Bi_2Se_3 yielded a direct bandgap of 0.31 eV (Fig. 3b), matching with the data reported in the literature for Bi_2Se_3 . The calculated direct bandgap values of the alloyed samples are summarized in Table 2. Correlating the sulfur content with the calculated bandgaps, we find that the bandgap increases with higher sulfur content in the sample. Particularly, replacing 15.2% of the chalcogen content with sulfur results in a nearly 40% larger bandgap than that of Bi_2Se_3 .

Fig. 3c shows the real (*n*) and imaginary (*k*) parts of the complex refractive index of $\text{Bi}_2\text{Se}_{2.64}\text{S}_{0.36}$ obtained by fitting the experimental reflection spectrum with a multiple Drude–Lorentz oscillator model, as detailed in Fig. S6 and Table S2 (ESI†). The values of *n* at the wavelength corresponding to the bulk energy bandgap are compared for the pure (6.34)³⁵ and alloyed (4.90) $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ TIs and are qualitatively in compliance with the Moss relation (Table 3).³⁶ However, the metallic surface states result in the absence of an absorption edge in TIs, rendering the Moss relation as undefined. In addition, in

Table 3 *n* at the wavelength corresponding to the bandgap for pure and sulfur alloyed Bi_2Se_3

Material	E_g [eV]/ λ_g [μm]	<i>n</i> at the corresponding bandgap	
		Moss relation ³⁶	Experimental
Bi_2Se_3	0.31/4.0	4.3	6.34 ³⁵
$\text{Bi}_2\text{Se}_{2.64}\text{S}_{0.36}$	0.38/3.26	4.1	4.90 (this work)

highly doped samples, where the Fermi level is pinned to the conduction band, a Moss–Burstein shift is manifested due to the metallicity of the bulk.^{37–39} Interestingly, the losses manifested in the imaginary part of the refractive index are significantly smaller than previously reported chalcogenide topological insulators.^{7,35,40}

Further characterization of the alloy TIs was exercised by measuring their electrical characteristics. Devices were fabricated on 300 nm Si/SiO₂ (Fig. 4a) with metallization of Ti/Au contacts. Room temperature *I*–*V* measurements at varying gate voltages show an effective field effect (Fig. 4b and c), with some nonlinear character arising from a metal–semiconductor interface at the contacts. This is indicative of an unpinned Fermi-level in the alloyed samples as well as a narrow bulk bandgap semiconductor rather than the metallic behavior of highly doped topological insulators. Furthermore, temperature-dependent measurements (see the ESI† for details) demonstrate a typical metallic behavior, where the resistance increases with increasing temperature (Fig. 4c inset), as opposed to a semiconductor. This characteristic metallic behavior stems from a decrease in the mean free path of electrons between collisions as temperature increases. Since the bulk of the alloys exhibits a bandgap that was measured optically, the metallic transport is exclusively attributed to surface states, implying that the topological phase is maintained after alloying with sulfur. Yet, the origin of the varying temperature coefficient of resistance remains unclear. Notably, monolayer samples are highly resistive, indicating that the topological phase is not supported in monolayer $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$. We associate the electrical resistance with the contact interface; however, at this stage, these observations are not conclusive and may require further investigation.

Conclusions

We have grown $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ by CVD from powder precursors on several substrates, obtaining isolated crystals and continuous films. The formation of the latter is promoted by graphene-covered substrates, probably due to enhanced diffusion and reduced surface chemical reactivity. Additionally, smaller $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ crystals tend to have higher sulfur content (12–15%). We associate this trend with the increased surface area of smaller crystals, leading to higher sulfur diffusion. Optical measurements show that the bulk energy bandgap was tuned by ~40% with a sulfur content of ~15%, a reasonable value compared with, e.g., InGaAs.⁴¹ The bandgap tuning affected the optical constants and reduced the *n* value of $\text{Bi}_2\text{Se}_{2.64}\text{S}_{0.36}$ by ~25% compared to that of Bi_2Se_3 , in qualitative agreement with the Moss relation.³⁶ Moreover, the alloy is characterized by remarkably low losses. *I*–*V* measurements demonstrate a field effect tuning of the device and a proven unpinned Fermi-level of $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$. The field effect tuning and the absence of Moss–Burstein shift indicate a lower density of defects. Interestingly, the Fermi-level resides on the valence band in the case of the alloyed TI, rather than in the case of pure Bi_2Se_3 . Furthermore, the temperature dependence of the resistance reveals a clear metallic behavior that stems from surface state-dominated



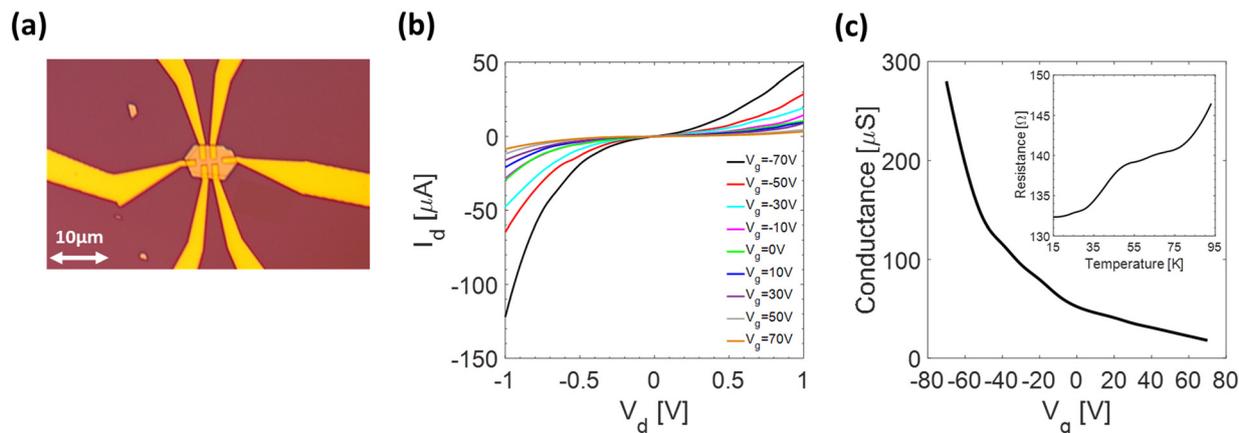


Fig. 4 (a) Optical microscope image of a $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ device. Gate-dependent (b) I_d - V_d and (c) conductance of a $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ device. Inset shows resistance as a function of the temperature of a $\text{Bi}_2\text{Se}_{(3-x)}\text{S}_x$ device.

transport. The coexistence of bulk bandgap and metallic transport is a conclusive proof of the conservation of the original topological properties of Bi_2Se_3 in the alloys. This work paves the way for the controlled growth of topological insulators, free from surface-state pinning, suitable for quantum optoelectronics and spintronics applications.

Author contributions

Sample preparation: Michal Poplinger, Pilkhaz Nanikashvili, Amaia Pesquera, Amaia Zurutuza, Ioanna Zergioti and Doron Naveh. Data collection: Michal Poplinger, Chen Stern, Pilkhaz Nanikashvili, Adi Levi, Rajesh K. Yadav, Sukanta Nandi, Yuxiao Wu, Avinash Patsha. Theoretical and computational results: Dimitris Kaltsas, Leonidas Tsetseris, Ashwin Ramasubramaniam, Tomer Lewi, Sukanta Nandi, Michal Poplinger and Doron Naveh. Study conception and design: Doron Naveh, Ioanna Zergioti. Study supervision: Doron Naveh. Draft manuscript preparation: the manuscript was written through the contribution of all authors. All authors have approved the final version of the manuscript.

Conflicts of interest

There are no conflicts of interest to declare.

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